

Atty Docket No 100-22900 [P05685]

## **DECLARATION FOR PATENT APPLICATION**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

HIGH-VOLTAGE SILICON	CONTROLLED RECTIFIER	STRUCTURE	
the specification of which was amended on (if a		ereto or was filed on as Application No and	
hereby state that I have reviewed and understand the contents of the above-identified specification, including he claims, as amended by any amendment referred to above.			
I acknowledge the duty to	disclose all information which	is material to patentability as defined in 37 CFR §1.56	•
patent or inventor's certific country other than the Uni	ate, or § 365(a) of any PCT In ted States, listed below and h	§ 119(a)-(d) or § 365(b) of any foreign application(s) for ternational application which designated at least one ave also identified below any foreign application for that of the application on which priority is claimed:	
Prior Foreign Application(s	s)	Priority Claim Yes	ned No
Number	Country	Day/Month/Year Filed	
I hereby claim the benefit	under 35 U.S.C. § 119(e) of a	ny United States provisional application(s) below.	
Application Number	Filing Date		
Application Number	Filing Date		
International application d the claims of this applicati first paragraph of 35 U.S.0 patentability as defined in	esignating the United States, on is not disclosed in the prior C. § 112, I acknowledge the d	United States application(s), or § 365(c) of any PCT listed below and, insofar as the subject matter of each or United States application in the manner provided by the uty to disclose all information which is material to e available between the filing date of the prior application pplication:	ne
Application Number	Filing Date	Status: Patented, Pending, Abandoned	
Application Number	Filing Date	Status: Patented, Pending, Abandoned	

## **PATENT**

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

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